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|-------|------|---|----------|------------------|---------|------------------|
| L1 | 26 | semiconductor and ((silicon adj oxide) same (plasma adj nitridation)) | USPAT | ADJ | ON | 2005/10/19 11:32 |
| L2 | 2 | semiconductor and ((silicon adj oxide) same (plasma adj nitridation)) | EPO | ADJ | ON | 2005/10/19 11:38 |
| L3 | 0 | semiconductor and ((silicon adj oxide) same (plasma adj nitridation)) | JPO | ADJ | ON | 2005/10/19 11:38 |
| L4 | 6 | semiconductor and ((silicon adj oxide) same (plasma adj nitridation)) | DERWENT | ADJ | ON | 2005/10/19 11:39 |
| L5 | 0 | semiconductor and ((silicon adj oxide) same (plasma adj nitridation)) | IBM_TDB | ADJ | ON | 2005/10/19 11:40 |
| L6 | 38 | semiconductor and ((silicon adj oxide) same (plasma adj nitridation)) | US-PGPUB | ADJ | ON | 2005/10/19 11:40 |